

17W
Docket No.: 0756-7275

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Hidekazu MIYAIRI, et al.)
Serial No. 10/808,499) Group Art Unit: 2857
Filed: March 25, 2004) Examiner: Jeffrey West
For: METHOD FOR TESTING)
SEMICONDUCTOR FILM, SEMICONDUCTOR)
DEVICE AND MANUFACTURING METHOD)
THEREOF)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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REQUEST FOR STATUS

Honorable Commissioner of Patents

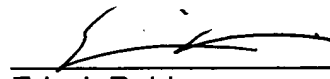
P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,


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